What is claimed is:

1. A method of manufacturing a head slider,

comprising the steps of :

forming a magnetizable layer, on a surface of a substrate whose thickness is greater than a length of said slider; and

cutting said wafer into a raw bar after forming the layers.

2. The method according to claim 1,

wherein said raw bar, whose thickness is greater than a length of said slider, is supported by a supporting jig in said machining step.

3. The method according to claim 1,

wherein dummy sections of a plurality of said raw bars are arranged on one side in said supporting jig, and

wherein air bearing surface patterns are formed on ABS faces of said raw bars by photolithography.

4. The method according to claim 1,

further comprising the steps of:

removing the dummy section from said raw bar after forming the air bearing surface patterns on the ABS face; and

cutting said raw bar so as to form the slider.

5. The method according to claim 1,

further comprising the step of:

removing the dummy section before cutting into said raw bar.

6. A method of manufacturing a magnetic head,

comprising the steps of:

forming a plurality of layers including a magnetizable layer on a surface of a substrate;

cutting said substrate so as to form a plurality of raw bars; and

removing a prescribed part of each raw bar, from one end face, in a direction of piling said layers.